



**Waseda University**

Research Institute for Science and Engineering

**Design of High Brightness Laser-Compton  
Light Source for EUV Lithography Research  
in Shorter Wavelength Region**

**Research Institute for Science and Engineering,  
Waseda University**

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# Contents

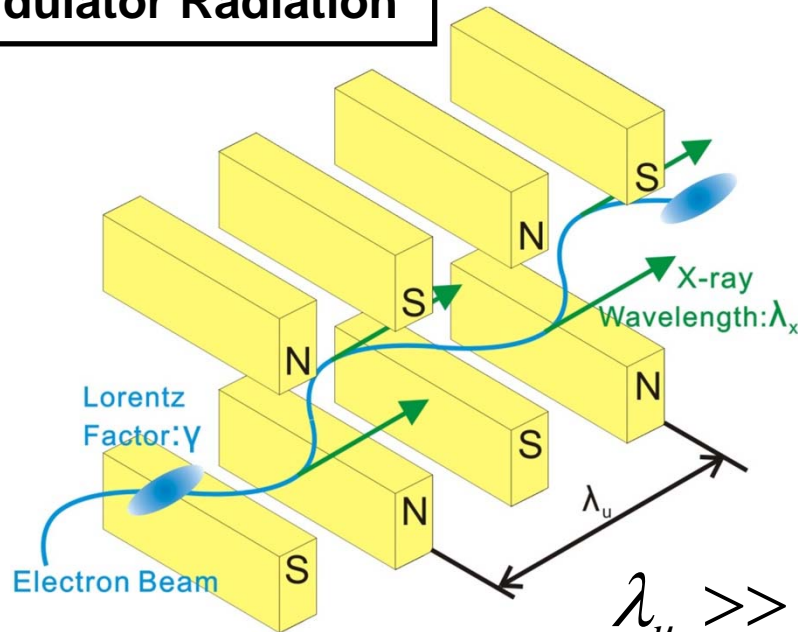
- **Laser Compton Scattering**
- **Laser-Compton Experiments**
- **Design of EUV Light Source**
  - **Low Repetition Case**
  - **High Repetition Case**
- **Summary**



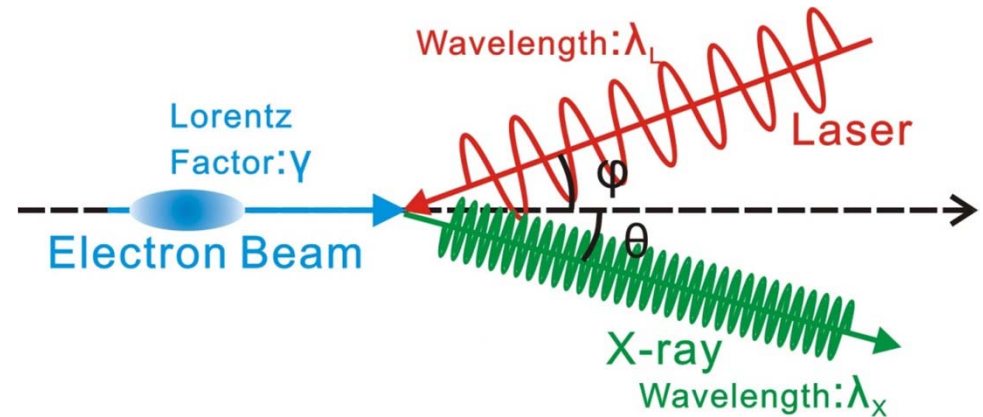
# Laser Compton Scattering

## Comparison of Undulator Radiation and Laser-Compton Scattering

### Undulator Radiation



### Laser-Compton Scattering



$$E_x = 2\gamma^2 \cdot hc / \lambda_u$$

$$\lambda_u \gg \lambda_L$$

$$E_x = 2\gamma^2 \cdot hc / (\lambda_L / (\cos \phi + 1 / \beta))$$

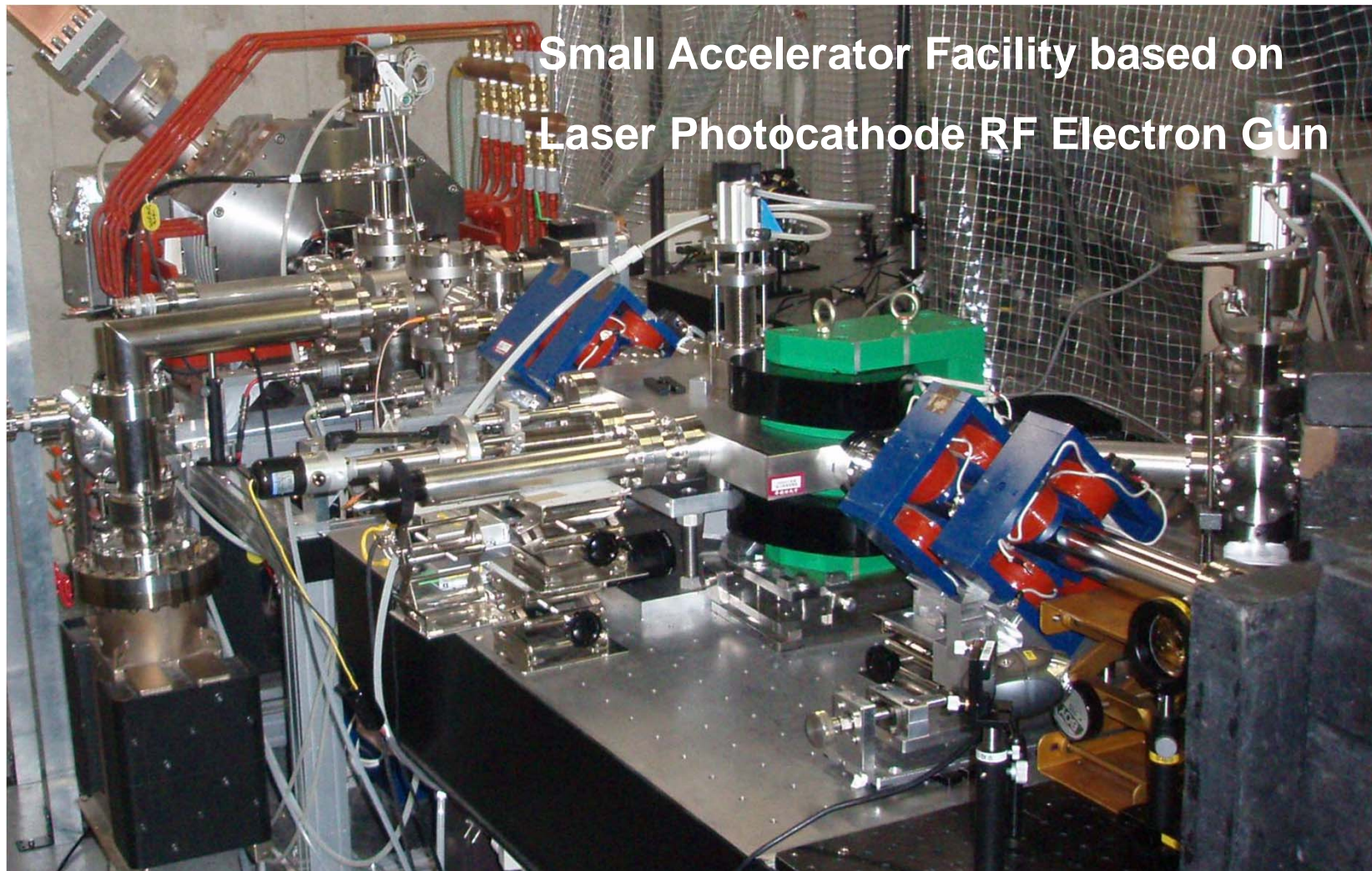
Undulation period can be shortened  
over 3-order of magnitude

High energy photon is  
produced with small  
accelerator system



# Laser-Compton Experiment

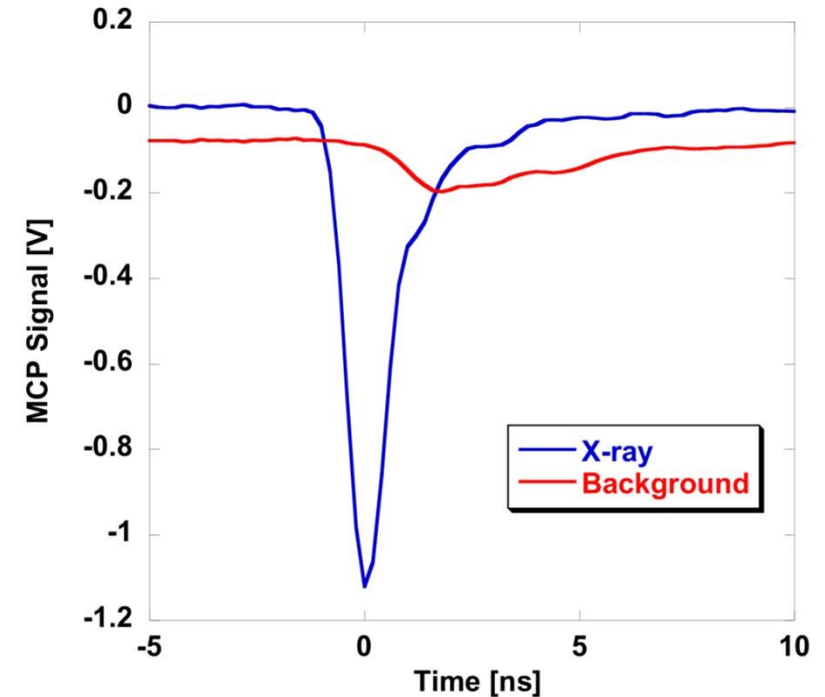
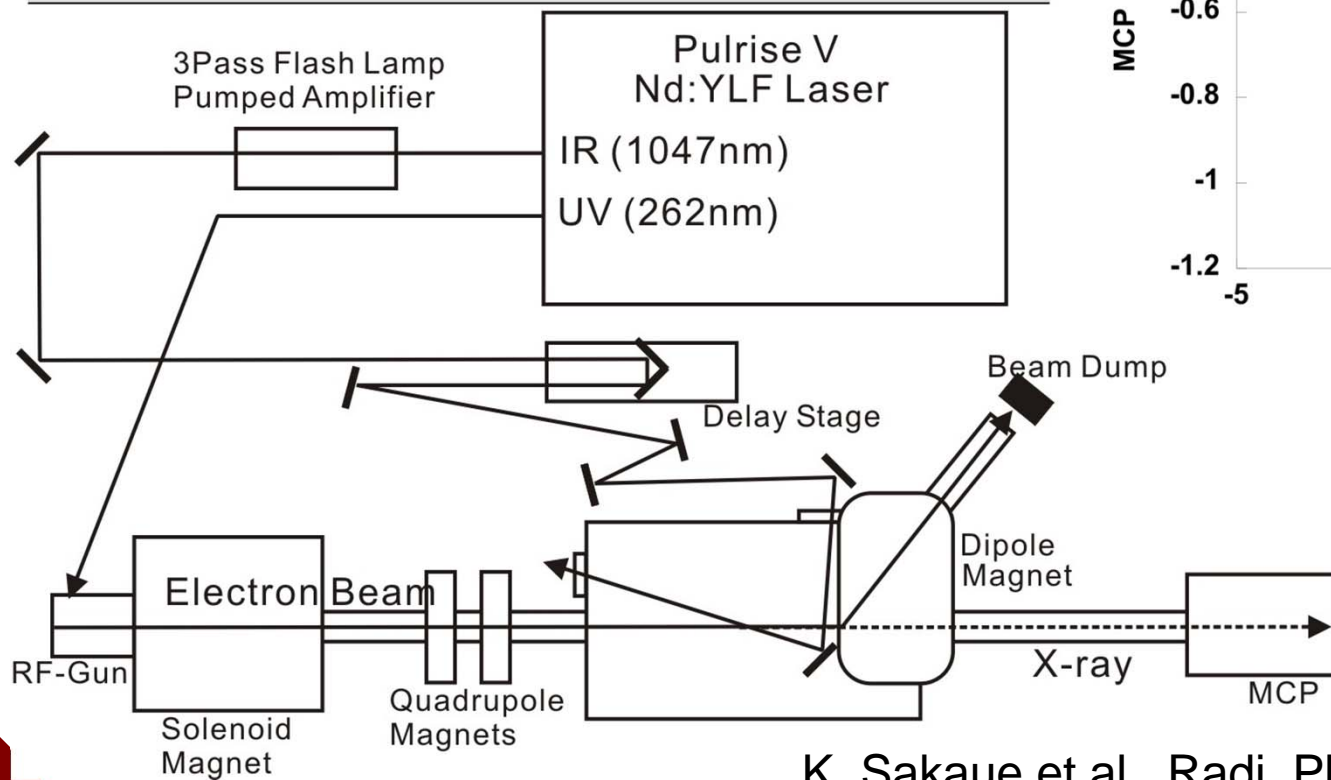
## Facility Outlook at Waseda University



# Soft X-ray Generation at Waseda

## Results of Soft X-ray Generation

Electron beam		Laser beam	
Energy	4.6 MeV	Wavelength	1047 nm
Bunch charge	350 pC	Pulse energy	36 mJ
Size (horizontal)	251 $\mu\text{m}$	Size (horizontal)	42 $\mu\text{m}$
Size (vertical)	56 $\mu\text{m}$	Size (vertical)	42 $\mu\text{m}$
Bunch length	10 ps (FWHM)	Pulse duration	10 ps (FWHM)



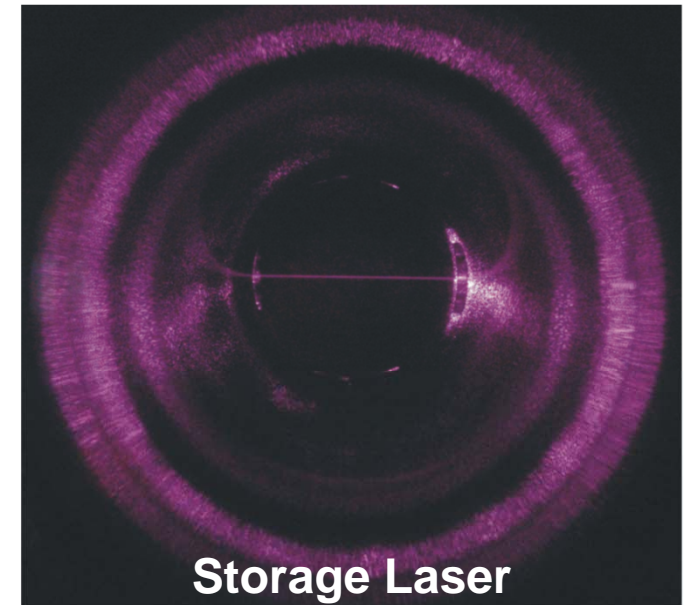
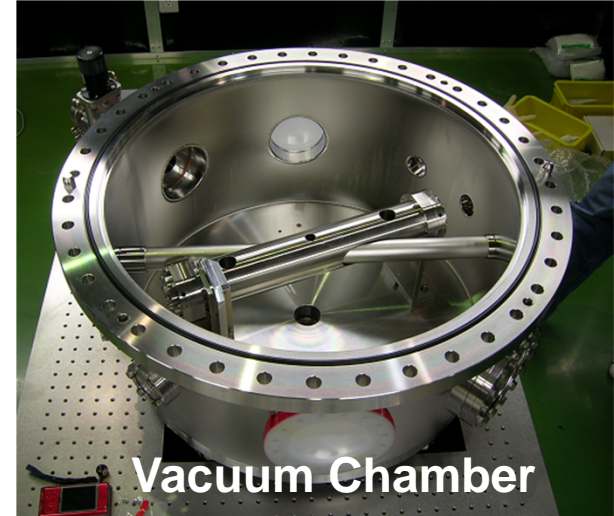
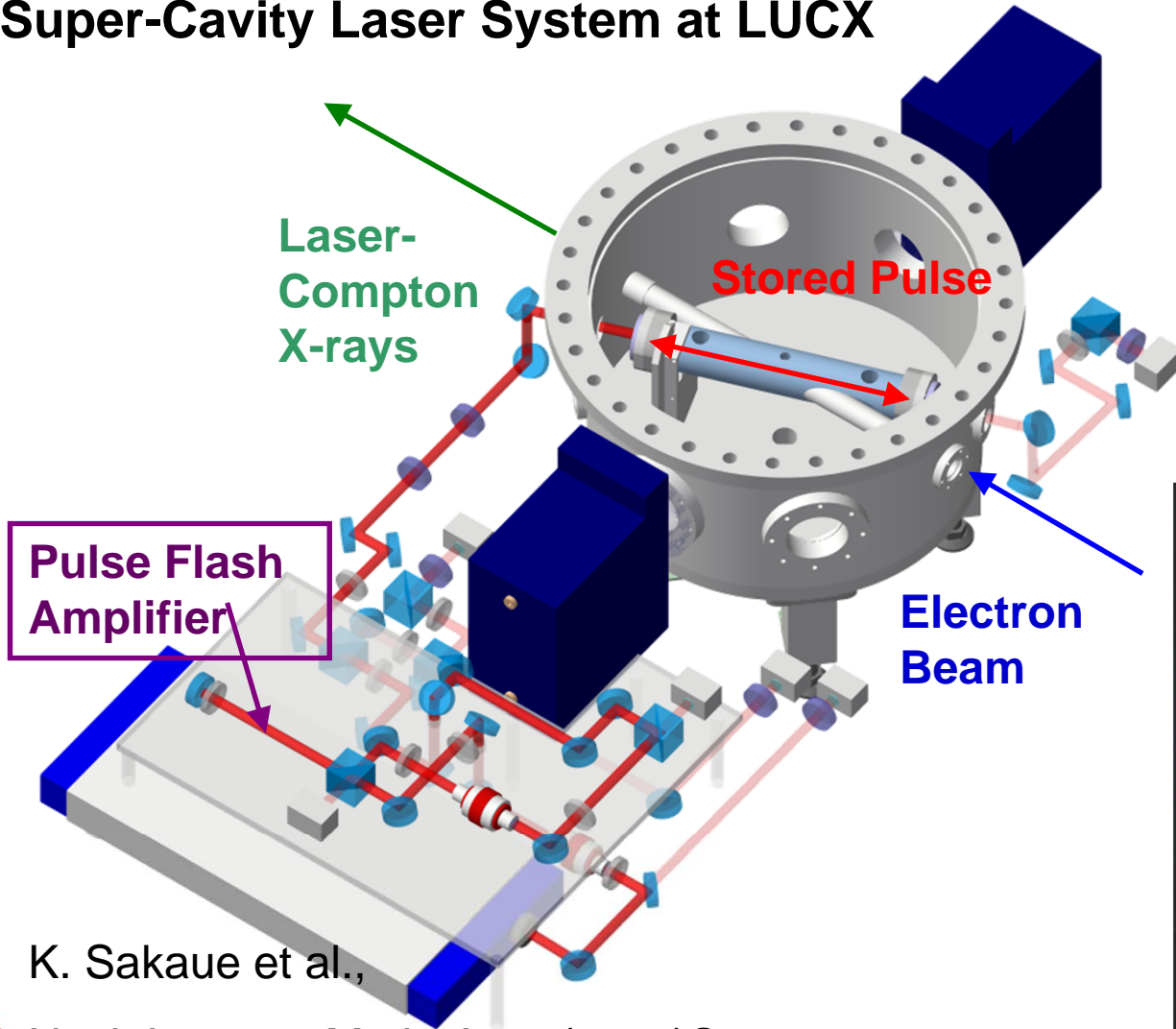
$3.3 \times 10^4$  Photons  
were produced  
in 1 pulse  
Ex~420eV (2.8nm)

K. Sakaue et al., Radi. Phys. Chem. 77(2008)1134



# Laser-Compton with Super-Cavity

## Super-Cavity Laser System at LUCX



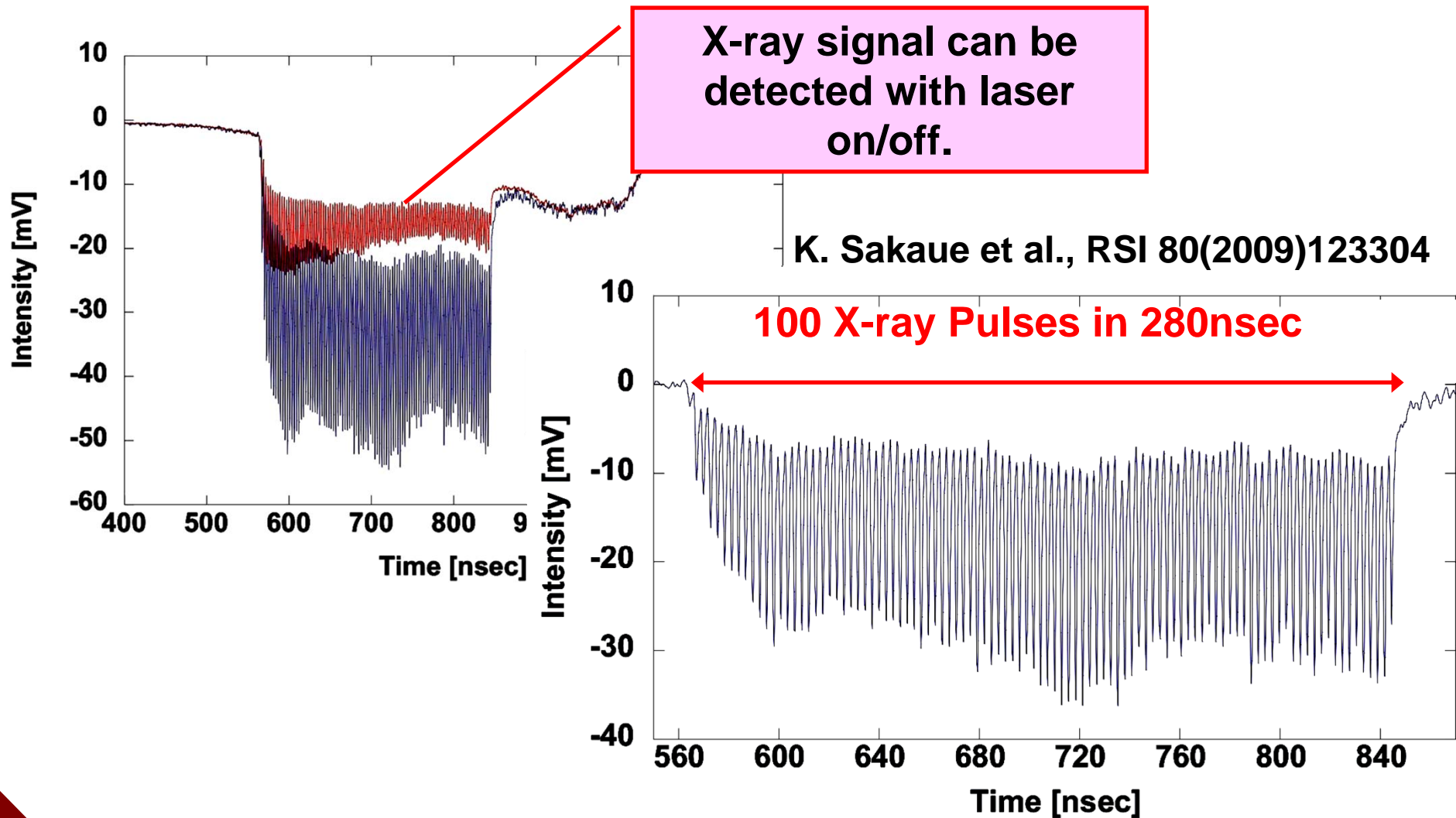
K. Sakaue et al.,

Nucl. Instrum. Meth. A637(2011)S107



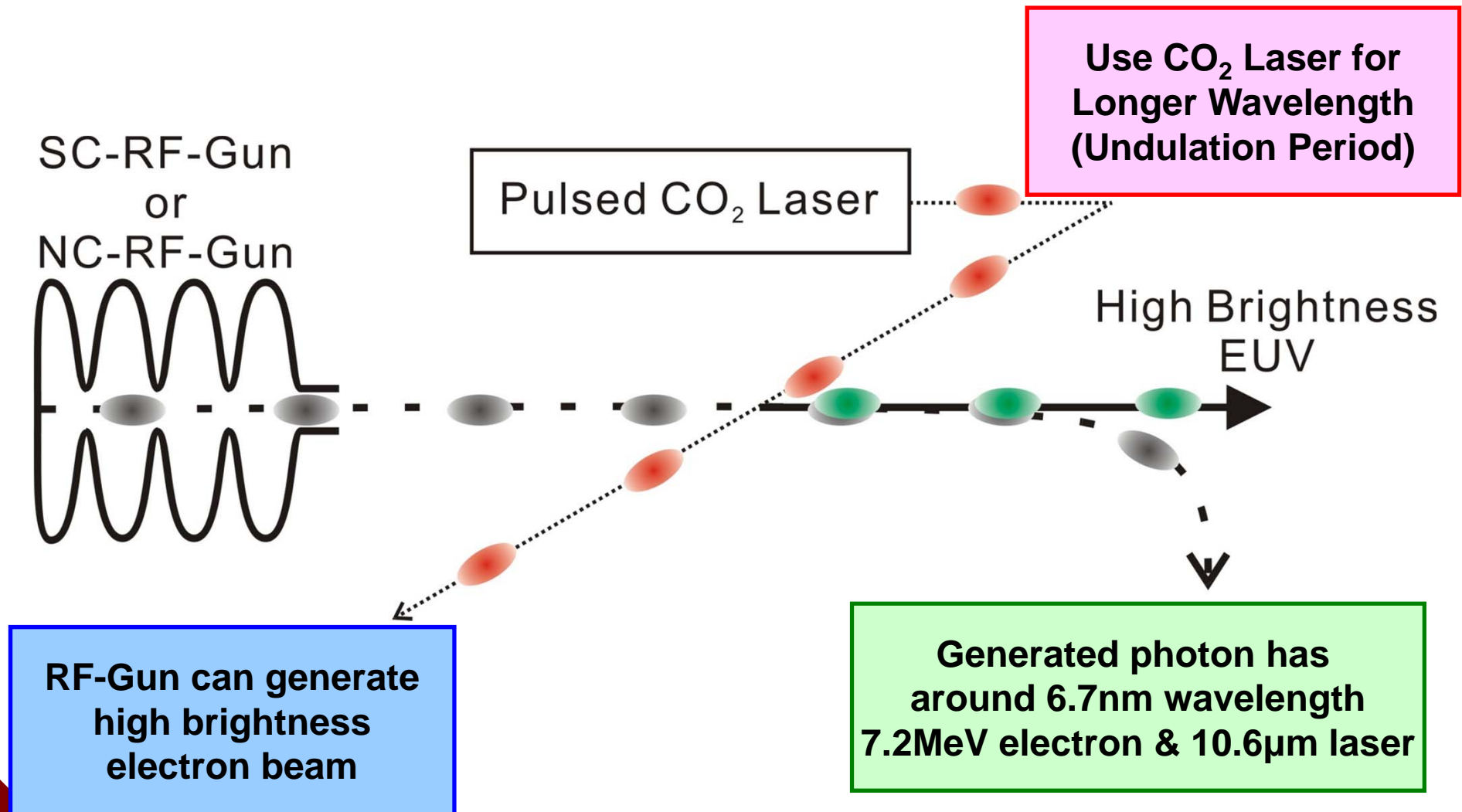
# Laser-Compton with Super-Cavity

## Waveform from Micro-Channel Plate



# Design of EUV Light Source

## Design of EUV Light Source based on Laser-Compton Scattering





# Design of EUV Light Source

We have 2 case of designs

“Low Rep. Case (100kHz)” and “High Rep. Case (100MHz)”

	100kHz	100MHz
Bunch charge	1nC/bunch	77pC/bunch
Bunch length	3psec (rms)	3psec
Pulse energy	1J/pulse	20 $\mu$ J/pulse
Pulse duration	20nsec	20psec
Enhancement	None	5000
Source Size	10 $\mu$ m	20 $\mu$ m
Colliding angle	0deg	5deg
EUV power	12.8 $\mu$ W/2%bw	1mW/2%bw

**Electron  
Beam**

**Laser**

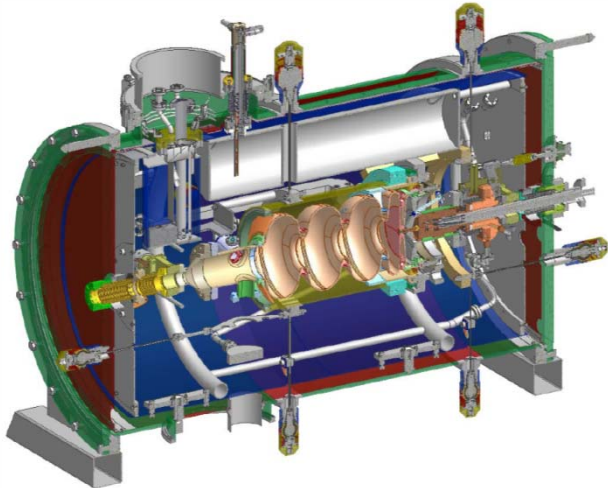
**EUV**



# EUV Light Source (Low Rep. Case)

## Components of Low Rep. Case

### Electron Accelerator



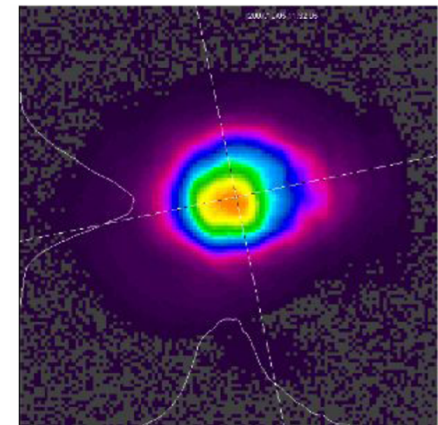
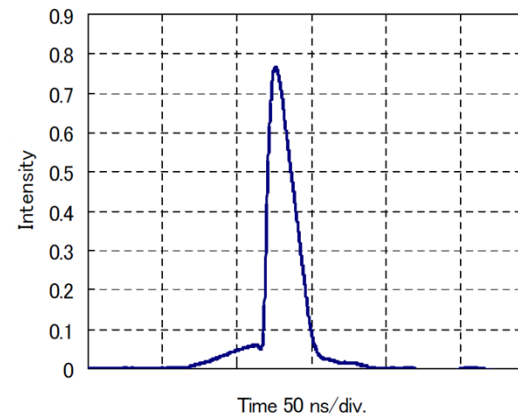
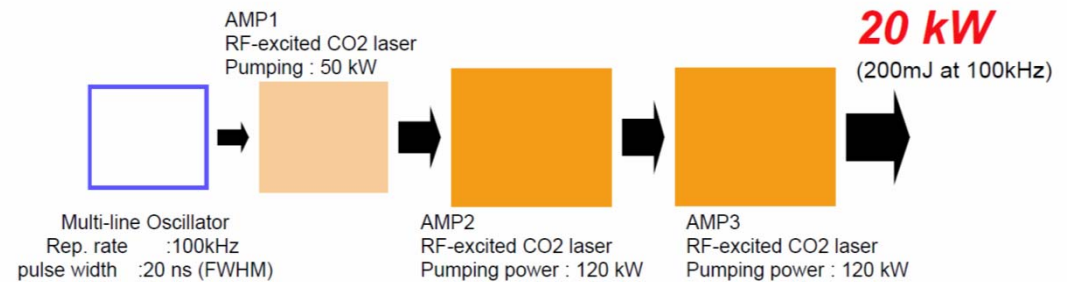
SC-RF-Gun (Teichert et al., FEL08)



NC-RF-Gun (Now under testing at KEK)



### CO<sub>2</sub> Laser



1J/pulse is also feasible technology

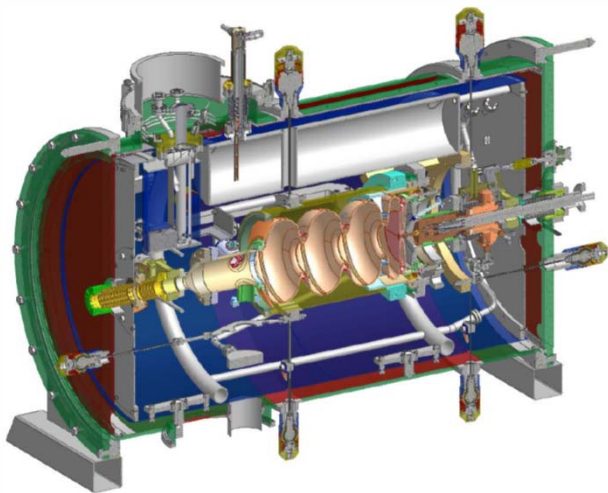
# EUV Light Source (High Rep. Case)

## Components of High Rep. Case (Electron Beam)

>Almost same requirements with ERL (Energy Recovery Linac)  
electron source

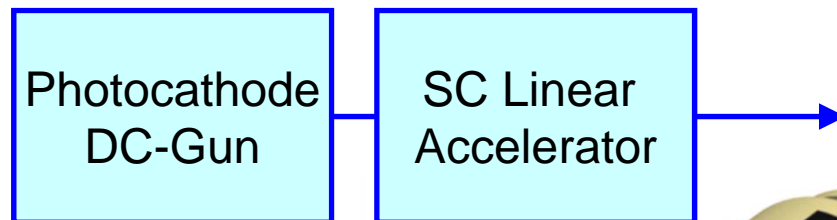
These will be mature in near future

### SC-RF-Gun



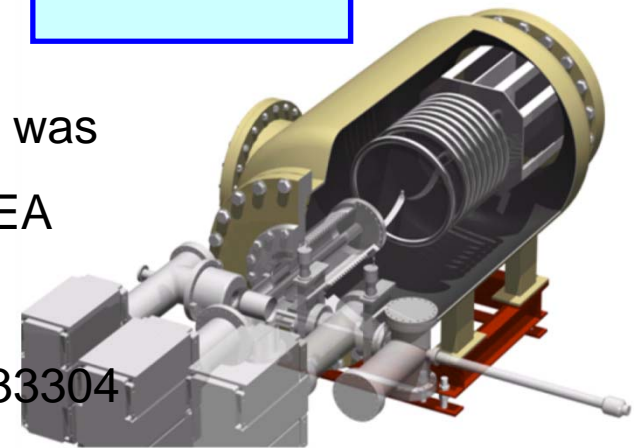
SC-RF-Gun (Teichert et al., FEL08)

### DC-Gun & SC Linac



500kV DC-Gun was  
achieved at JAEA

R. Nagai et al.,  
RSI 81(2010)033304

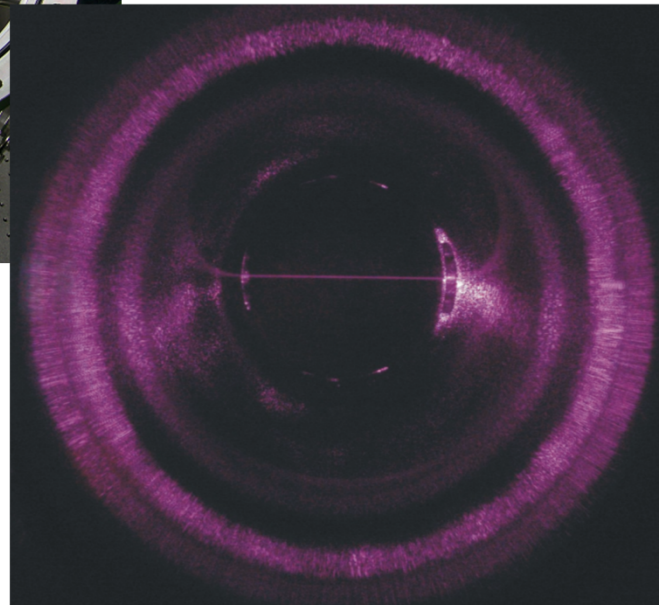
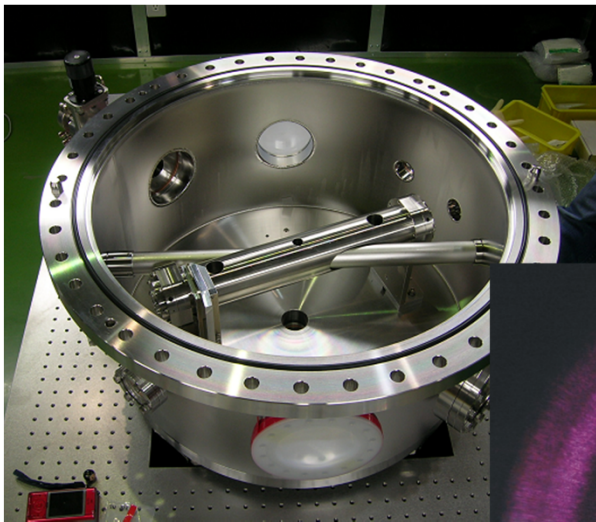


# EUV Light Source (High Rep. Case)

Components of High Rep. Case (Laser Beam)

>Need to use Super-cavity technology

Demonstrated at  $1\mu\text{m}$  wavelength K. Sakaue et al., RSI 80(2009)123304

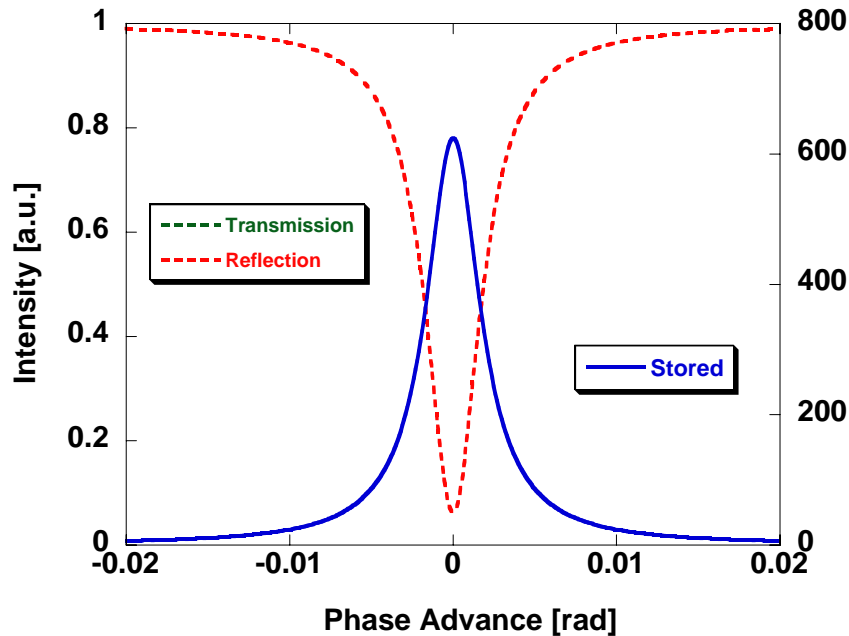


Need to R&D at  $10.6\mu\text{m}$   $\text{CO}_2$  laser storage in optical super-cavity with enhancement of 5000

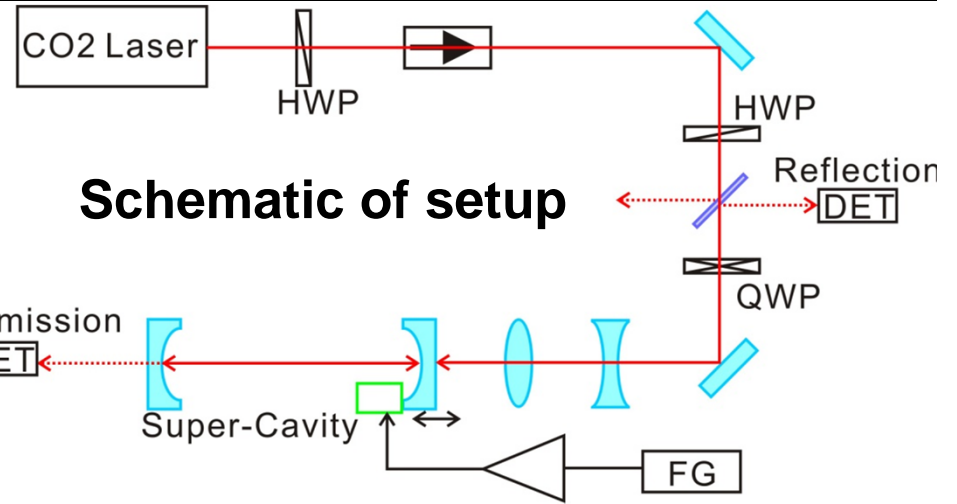


# CO2 Laser Super-Cavity R&D

We started R&D of  
CO2 laser Super-Cavity (CW)



Calculated results of  
enhancement in Super-cavity  
with commercial mirrors  
(HTrans Mirror and HRef Mirror)



CO2 laser Super-Cavity  
test bench



# CO2 Laser Super-Cavity R&D

## Study Plan of CO2 laser Super-Cavity

1 <sup>st</sup> step	CW storage demonstration	
2 <sup>nd</sup> step	High power test	Mirror damage test
3 <sup>rd</sup> step	Higher enhancement	Short pulsed CO2 laser development
	Need super-mirror development	Need short pulse demonstration Now considering QCL, DFG...



# Summary

We have been developing a laser-Compton scattering

Soft X-ray was demonstrated by 4.6MeV electron and 1 $\mu$ m laser

Super-Cavity Laser-Compton scattering was performed

2 types of EUV light source designed by our experiences of laser-Compton scattering

<Low Rep. Case (100kHz)>

SC(NC)-RF-Gun and CO<sub>2</sub> laser will generate

10 $\mu$ W/2%b.w. EUV (6.7nm) <based on mature technologies

<High Rep. Case (100MHz)>

SC-RF-Gun (or DC-Gun+SC Linac) and CO<sub>2</sub> laser with Super-cavity

1mW/2%b.w. EUV (6.7nm) <Need R&Ds, already started at Waseda

